

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of:

Kazunari SEKIGAWA, et al.

Serial No.

Group Art Unit:

Confirmation No.

Filed: March 26, 2004

Examiner:

For: EXPOSING APPARATUS AND EXPOSING METHOD, FOR MASKLESS EXPOSURE  
OF SUBSTRATE TO BE EXPOSED, AND PLOTTER AND PLOTTING METHOD FOR  
DIRECTLY PLOTTING ON OBJECT TO BE PLOTTED

**PRELIMINARY AMENDMENT**

Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Sir:

Before examination of the above-identified application, please amend same as follows: